

Search Notes

Application/Control No.

10/776,256

Examiner

Arnel C. Lavarias

Applicant(s)/Patent under
Reexamination

CEMIC ET AL.

Art Unit

2872

SEARCHED

Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
Interference search (See attached)		11/18/2005	ACL

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
356/614,615,616,622,399,400,401 Limited class search (See attached)	11/18/2005	ACL
359/454,455 Limited class search (See attached)	11/18/2005	ACL
362/551,554,558 Limited class search (See attached)	11/18/2005	ACL
EAST text search (See attached)	11/18/2005	ACL